Notice of References Cited Application/Control No. 10/565,863 Examiner JOHN LEE Applicant(s)/Patent Under Reexamination TAKAISHI, YOSHITOMO Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,078,686 A	06-2000	Kim, Yeong-taeg	382/167
*	В	US-2001/0021269 A1	09-2001	Inoue, Hitoshi	382/169
*	O	US-6,296,387 B1	10-2001	Guillemaud, Regis	378/207
*	D	US-2003/0112921 A1	06-2003	Lang et al.	378/54
*	ш	US-6,819,794 B2	11-2004	Inoue, Hitoshi	382/169
	F	US-			
	G	US-			
	Ι	US-			
	_	US-			
	٦	US-			
	K	US-			
	┙	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν	62-266053A	11-1987	JP	Yamashita, Gentaro	
	0					
	Ρ					
	σ					
	R					
	Ø					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	V					
	w					
	х					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.